microMARK™ MCF RXe 200

System Solution for Laser Marking of Ophthalmic Glasses

3D-Micromac's microMARK[™] RXe200 is a premium quality marking device for all kinds of blocked lenses. Equipped with an optimized optical components setup and an large-sized magnification ratio this new generation of RX marking devices offers an increased depth of focus at lowest laser power operation on all materials.

microMARK[™] RXe200 offers:

- Stable XY axis system with Z measurement
- Laser power measurement
- Precise digital galvanometer mirror deflection system
- 20 selectable apertures
- Fully sealed beam path with integrated beam flush unit





microMARK™ MCF RXe 200 - System Configuration





Suitable for:

- Technical marking of spectacle lenses
- Branding functionality for unblocked lenses on request

Benefits

- High quality engraving with accurate contrast adjustment on a variety of spectacle lenses and coatings
- Small footprint
- Low investment and operating cost
- Easy retrofit of automated handling system at customer's site on request

Suitable for	- Blocked lenses (mineral, plastic) with a maximum size of 80 mm x 35 mm (D x H above block reference)
Productivity	150 blocked lenses/hour with automatic handling
System accuracy	• ± 0.1 mm
Laser source	Industrial proven long life excimer laser source193 nm
Beam delivery unit	 Galvanometer scanner with mirror deflecting system Marking field of Ø 80 mm Power management
Software	 Proven ULM software version 4.0.0.0 (or higher), Interface to lensware LMS / ULM Socket Connection standard
Safety	• Laser class 1
Options	Automatic handling system
Dimensions	 960 x 600 x 1200 mm³ (W x H x D) (manual and automated system)

Changes in accordance to technical progress are reserved.

3D-Micromac AG